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Materials, Technology and Reliability for Advanced Interconnects and Low-k Dielectrics
Editors: G. S. Oehrlein, K. Maex, Y. -C. Joo, S. Ogawa and J. T. Wetzel
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EDITORS:

G.S. Oehrlein

University of Maryland
College Park, Maryland, U.S.A.

K. Maex

IMEC
Leuven, Belgium

Y.-C. Joo

Seoul National University
Seoul, Korea

S. Ogawa

Matsushita Electronics Corporation
Kyoto, Japan

J.T. Wetzel

International SEMATECH
Austin, Texas, U.S.A.



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